Docket No.:0756-7718

MAY 1 1 2009

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Koichiro TANAKA, et al.

Serial No. 10/582,013 / ) Group Art Unit: 4118

Filed: June 7, 2006 ) Examiner: Hung Nguyen

For: LASER IRRADIATION METHOD AND )

LASER IRRADIATION APPARATUS )

## **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA 22313-1450, on <u>May 8. 2009</u>

**SECOND REQUEST FOR STATUS** 

Honorable Commissioner of Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

To date the undersigned attorney of record has received no action in the aboveidentified patent application. Please provide the undersigned with a status report of the application in writing.

Respectfully submitted,

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